

PROCEEDINGS OF SPIE

High-Power Diode Laser Technology XVIII

Mark S. Zediker
Editor

2–4 February 2020
San Francisco, California, United States

Sponsored and Published by
SPIE

Volume 11262

Proceedings of SPIE 0277-786X, V. 11262

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High-Power Diode Laser Technology XVIII, edited by Mark S. Zediker,
Proc. of SPIE Vol. 11262, 1126201 · © 2020 SPIE · CCC code:
0277-786X/20/\$21 · doi: 10.1117/12.2569821

Proc. of SPIE Vol. 11262 1126201-1

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Author(s), "Title of Paper," in *High-Power Diode Laser Technology XVIII*, edited by Mark S. Zediker, Proceedings of SPIE Vol. 11262 (SPIE, Bellingham, WA, 2020) Seven-digit Article CID Number.

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510632875

ISBN: 9781510632882 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

SPIE.org

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